The

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ventor:

Truskett, Van N.

App. No.:

10/687,519

GPAU:

1775

Filing Date:

October 16, 2003

Examiner:

Archene A. Turner

Dkt. No.:

P75-17-03

Conf. No.: 5222

For: Low Surface Energy Templates

INFORMATION DISCLOSURE STATEMENT

Mail Stop AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure and pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98. The undersigned brings the patents, publications, applications or other information identified in the attached:

Form(s) PTO/SB/08A and/or PTO/SB/08B or PTO/1449

Other:

to the Examiner's attention in the above-identified application. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed:

before the mailing date of a first Office action on the merits or before the mailing date of a first Office action after the filing of a request for continued examination under § 1.114. Therefore, no fee is believed required.

Applicants do not believe that any additional fees are due, but if the Commissioner believes additional fees are due, the

Compositioner is hereby authorized to charge any fees which may be uired, or credit any overpayment, to Deposit Account Number 502650.

CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as either First Class Mail or Express Mail, in an envelope addressed to the Commissioner

Signed: Typed Name: I

for Patents.

Katrina Prati

Date: 3-30-05

Respectfully Submitted,

Kenneth C. Brooks,

Reg. No. 38,393

Legal Department

Molecular Imprints, Inc.

P.O. Box 81536

Austin, TX 78758-1536

(512) 339-7760

(512) 491-8918 (fax)

PTO/SB/08A (08-03)

Pages, Columns, Lines,

Approved for use through 7/31/2006. OMB 0651-0031 U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number

Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Foreign Patent Document

(use as many sheets as necessary)

Sheet 1 of 7

Complete if Known								
APPLICATION NUMBER	10/687,519							
FILING DATE	10/16/2003							
FIRST NAMED INVENTOR	Truskett et al.							
Group Art Unit	1775							
Examiner Name	Turner, Archene A.							
Attorney Docket Number	P75-17-03							

Date of Publication of

Initials*	Cite No. ¹	Office Numb	oer ⁴	Kind Code ⁵ (<i>if known</i>)				Document D-YYYY	Where Relevant Passages or Relevant Figures Appear	T°
	E1	6,391,217	B2	Scha	ffer et al.	5/21/200	2			
	E2	6,517,977	B2	Resn	ick et al.	2/11/2003				
	E3	2004/0007799	A1	Choi	et al.	1/15/2004				
•	E4	2004/0021254	A1	Sree	nivasan et al.	2/5/2004		· · · · · · · · · · · · · · · · · · ·		
	E5	2004/0021866	A1	Watts	Watts et al.					
	E6	2004/0022888	A1	Sreei	Sreenivasan et al.					
	E7	2004/0065252	A1	Sreei	Sreenivasan et al.					
	E8	2002/0177319	A1	Chou	Chou		02			
	E9	2004/0046271	A1	Watts	Watts		4			
	E10	6,518,189	B1	Chou		2/11/200	3			
	E11	2004/0192041	A1	Jeon	g et al.	9/30/200	4			
	E12	6,828,244	B2	Chou		12/7/200	4			
	E13	6,809,356	B2	Chou		10/26/20	04			
	E14	2004/0197843	A1	Chou	et al.	10/7/200	4			
	E15	2004/0156108	A1	Chou	et al.	8/12/200	4			
	E16	2004/0137734	A1	Chou	et al.	7/15/200	4			
	E17	2004/0131718	A1	Chou	et al.	7/8/2004				
	E18	2004/0118809	A1	Chou	et al.	6/24/200	4			

FOREIGN PATENT DOCUMENTS

Name of Patentee or Applicant of

Examiner	Date			
Signature	Considere	ed		

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number Substitute for form 1449A/PTO Complete if Known 10/687,519 APPLICATION NUMBER INFORMATION DISCLOSURE FILING DATE 10/16/2003 STATEMENT BY APPLICANT FIRST NAMED INVENTOR Truskett et al. 1775 Group Art Unit (use as many sheets as necessary) Turner, Archene A. Examiner Name P75-17-03 Sheet 2 of Attornev Docket Number

				FOREIGN	PATENT DOCUMENTS				
Examiner Initials*	Cite No.1	Office Number ⁴		Ment Kind Code ⁵ (if known)	Name of Patentee or Applicant o Cited Document			Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Τ ⁶
	E19	2004/0046288	A1	Chou	3/11/2	004			
	E20	2003/0080472	A1	Chou	5/1/20	03	Ì		

	E19	2004/0046288	A1	Chou	3/11/2004	
	E20	2003/0080472	A1	Chou	5/1/2003	
	E21	2003/0034329	A1	Chou	2/20/2003	
	E22	2002/0042027	A1	Chou et al.	4/11/2002	
	E23	5,594,042		Glover et al.	1/14/1997	
	E24	5,629,095		Bujanowski et al.	5/13/1997	
	E25	5,861,467		Bujanowski et al.	1/19/1999	
	E26	5,331,020		Brown et al.	7/19/1994	
	E27	4,617,238		Crivello et al.	10/14/1986	
	E28	6,580,172	B2	Mancini et al.	6/17/2003	
	E29	4,722,878		Watakabe et al.	2/2/1988	
	E30	2002/0175298	A1	Moniwa et al.	11/28/2002	
	E31	10/670,980		Sreenivasan et al.	9/25/2003	
	E32	10/706,537		Sreenivasan et al.	11/12/2003	
	E33	10/833,240		Watts et al.	4/27/2004	
-	E34	10/895,214		Voison	7/20/2004	
	E35	11/027,473		Bailey et al.	12/30/2004	
	E36	10/917,761		McMackin et al.	8/13/2004	·

Examiner Signature	Date Considered	

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number Substitute for form 1449A/PTO Complete if Known APPLICATION NUMBER 10/687,519 INFORMATION DISCLOSURE FILING DATE 10/16/2003 STATEMENT BY APPLICANT FIRST NAMED INVENTOR Truskett et al. Group Art Unit 1775 (use as many sheets as necessary) Examiner Name Turner, Archene A. Sheet 3 of Attorney Docket Number P75-17-03

				FOREIGN	PATENT DOCU	MENTS			·	
Examiner Initials*	Cite No. ¹			Cited Document Cited D		Publication of Document OD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Т		
	E37	10/948,511		Xu et	t al.	9/23/200	4		· · · · · · · · · · · · · · · · · · ·	
	E38	10/967,740		Xu et	t al.	10/18/2004				
	E39	10/919,224		Xu et	et al. 8/16/2004		4			
	E40	11/051,941		МсМ	ackin et al.	2/4/2005	;			
	E41	11/026,821		Wills	on et al.	12/30/20	04			
	E42	4,512,848		Deck	man et al.	4/23/198	5			
	E43	2001/0044075	A1	Nishi	Nishimura et al.		01			
	E44	6,517,995	B1	Jaco	Jacobenson et al.		3	·		
	E45	5,369,722		Hemi	ing et al.	11/29/19	94			
	E46	6,475,704	B1	lwasa	aki et al.	11/5/200	2			

Examiner	Date	
Signature	Considered	

6/10/2004

4/6/2004

9/26/2002

2/22/2005

2/28/2005

2/28/2005

7/2/1991

2/11/1997

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

Young et al.

Hofmann et al.

Robinson et al.

Willson et al.

Harakal et al.

Xu et al.

Xu et al.

Stephens

F47

E48

E49

E50

E51

E52

E53

E54

2004/0110856

2002/0135099

11/062,420

11/068,397

11/068,174

5,028,366

5,601,641

6,716,754

A1

B2

Α1

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number Substitute for form 1449A/PTO Complete if Known APPLICATION NUMBER 10/687,519 INFORMATION DISCLOSURE

10/16/2003 FILING DATE STATEMENT BY APPLICANT FIRST NAMED INVENTOR Truskett et al. 1775 Group Art Unit (use as many sheets as necessary) Examiner Name Turner, Archene A. P75-17-03 Sheet 4 of Attorney Docket Number

FOREIGN PATENT DOCUMENTS										
Examiner Initials*	Cite No.1	Office 3	Foreign Patent Doo Number ⁴	ument Kind Code ⁵ (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T [®]		

E55	5,849,209		Kindt-Larsen et al.	12/15/1998	
E56	5,849,222		Jen et al.	12/15/1998	
		·			
	-				
-					

Examiner		Date		
Signature		Considered		

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional). 2 See Kinds Codes of USPTO Patent Documents at www.uspto.gog or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the Indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.

Substitute fo	r form 1449A/I	то		Complete if Known			
INE	ORMATION	ו חופרו ר	CLIDE	APPLICATION NUMBER	10/687,519		
	ATEMENT I			FILING DATE	10/16/2003		
l "'	XI EIVIEIVI I	DI AII L	IOAITI	FIRST NAMED INVENTOR	Truskett et al.		
_				Group Art Unit	1775		
(u	se as many shee	ts as necessar	Y)	Examiner Name	Turner, Archene A.		
Sheet	5	of	7	Attorney Docket Number	P75-17-03		

Office I	7199 /114016 5724 10289	nd Code ⁵ known)	Name of Patentee or Applicant of Cited Document Chou Chou et al.	Date of Publication of Cited Document MM-DD-YYYY 1/24/2002 12/29/2004 2/4/1999 2/6/2003 9/25/2003 12/4/2003	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
WO 2004/ WO 99/05 WO 03/01 WO 03/07	7114016 5724 10289 79416		Chou et al. Chou et al. Chou et al. Chou	12/29/2004 2/4/1999 2/6/2003 9/25/2003		
WO 99/05 WO 03/01 WO 03/07	79416		Chou et al. Chou et al. Chou	2/4/1999 2/6/2003 9/25/2003		
WO 03/01 WO 03/07	79416		Chou et al.	2/6/2003 9/25/2003		
WO 03/07	79416		Chou	9/25/2003		
			·			
WO 03/09	99536		Chou et al.	12/4/2003		Ī
		1		1		

Examiner		Date	
Signature		Considered	
	1		

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

Substitute for form 1449A/PTO				Complete if Known		
INFO	RMATION	DISCLO	SURE	APPLICATION NUMBER	10/687,519	
STATEMENT BY APPLICANT				FILING DATE	10/16/2003	
				FIRST NAMED INVENTOR	Truskett et al.	
(USE	as many sheets	as necessar)	V)	Group Art Unit	1775	
Sheet	6	of	7	Examiner Name	Turner, Archene A.	
				Attorney Docket Number	P75-17-03	

OTHER PRIC	OR ART -	NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	E63	Colburn et al., Step and Flash Imprint Lithography for sub-100 nm Patterning, Proceedings of SPIE Vol. 3997, pp. 453 - 457, 1/1/2000	
* *	E64	Chou et al., Nanoimprint Lithography, Journal of Vacuum Science Technolgoy B 14(16), pp. 4129-4133, 11/1/1996	
•	E65	Colburn et al., Development and Advantages of Step-and-Flash Lithography, Solid State Technology, 7/1/2001	
···	E66	Resnick et al., High Resolution Templates for Step and Flash Imprint Lithography, Journal of Microlithography, Microfabrication, and Microsystems. Vol 1. No. 3., 10/1/2002	
	E67	Colburn et al., Characterization and Modeling of Volumetric and Mechanical Properties for Step and Flash Imprint Lithography Photopolymers, Journal of Vacuum Science Technology. Vol b. 19(6), 11/1/2001	
	E68	Yu et al., Properties of Fluorinated Amorphous Diamond Like Carbon Films by PECVD, Applied Surface Science 219 (3-4); pp. 228-237, 12/1/2003	
	E69	Compon et al., Electroanalysis at Diamond-Like and Doped-Diamond Electrodes, Electroanalysis 15(17); pp. 1349-1363, 9/1/2003	
	E70	Mansano et al., Protective Carbon Layer for Chemical Corrosion of Stainless Steel, Diamond and Related Materials 12 (3-7); pp. 749-752, 3/1/2003	
	E71	Butter et al., Production and Wetting Properties of Fluorinated Diamond-Like Carbon Coatings, Thin Solid Films, 311(1-2); pp. 107-113, 12/31/1997	

Examiner Signature	Date Considered	

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance

and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending on the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450.. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Substitute for form 1449A/PTO				Complete if Known		
INFO	RMATION	DISCLO	SURE	APPLICATION NUMBER	10/687,519	
STATEMENT BY APPLICANT				FILING DATE	10/16/2003	
				FIRST NAMED INVENTOR	Truskett et al.	
(us	e as many sheets	as necessary	v)	Group Art Unit	1775	
Sheet	7	of	7	Examiner Name	Turner, Archene A.	
				Attorney Docket Number	P75-17-03	

THE DOLOD ADT. NON BATENT LITEDATURE BOOKINENTS

Examiner

Signature

OTHER PRIC	K ARI -	NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	E72	Hakovirta et al., Heat Resistance of Fluorinated Diamond-Like Carbon Films, Diamond and Related Materiasl 10(8); pp. 1486-1490, 8/1/2001	
	E73	Zhu et al., The Improvement of the Oxidation Resistance of TiAl Alloys by Fluorine Plasma- Based Ion Implantation, Surface and Coatings Technology 158; pp. 502-507, 9/1/2002	
	E74	Yao et al., Structural, Mechanical and Hydrophobic Properties of Fluorine-Doped Diamond-Like Carbon Films Synthesized by Plasma Immersion Ion Implantation and Deposition (PIII-D), Applied Surface Science 230; pp. 172-178, 4/17/2004	
	E75	Bailey et al., Step and Flash Imprint Lithography: Defect Analysis, Journal of Vacuum Science, B 19(6), pp. 2806-2810, 11/1/2001	
	E76	Bailey et al., Step and Flash Imprint Lithography: Template Surface Treatment and Defect Analysis, Journal of Vacuum Science, B 18(6), pp. 3572-3577, 11/1/2000	
	E77	Schneider et al., Stripes of Partially Fluorinated Alkyl Chains: Dipolar Langmuir Monolayers	

Date

Considered

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance

and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending on the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450.. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.